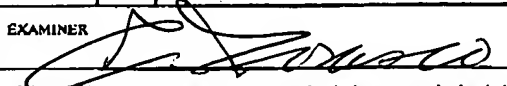


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M12-2513		SERIAL NO. 10/808,675	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT H. Daniel Dulman et al.			
					FILING DATE 03/24/04		GROUP 1756	
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
AA	6,312,854 B1	11/01	Chen et al.					
AB	6,465,138 B1	10/02	Stanton					
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AG								
AH								
AI								
AJ								
AK								
AL								
FOREIGN PATENT DOCUMENTS								
Document Number	Date	Country	Class	Subclass	Translation			
AM					Yes	No		
AN								
AO								
AP								
AQ								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
AR								
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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AE	AA	5,308,721	05/94	Garofalo et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
AE	AR	Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method",					
		19th Annual BACUS Sympos. on Photomask Technology, Monterey, CA, 9/99, SPIE Vol. 3873 (1999), pp. 288-296.					
AE	AS	Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method					
		(III)", 20th Annual BACUS Sympos. on Photomask Technology, Proceedings of SPIE Vol. 4186 (2001), pp.801-809.					
	AT						
EXAMINER A. J. Foushee				DATE CONSIDERED 12/06			
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